



03500.017136.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Holly C. Rickman
NOBUHIRO YASUI, ET AL.)	
	:	Group Art Unit: 1773
Application No.: 10/656,242)	
	:	
Filed: September 8, 2003)	
	:	
For: FUNCTION DEVICE AND METHOD)	
FOR MANUFACTURING THE	:	
SAME, PERPENDICULAR)	
MAGNETIC RECORDING MEDIUM,	:	
MAGNETIC RECORDING/)	
REPRODUCTION APPARATUS	:	
AND INFORMATION PROCESS)	
APPARATUS	:	July 14, 2005

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the cited articles and foreign documents are also enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

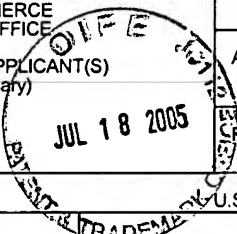
Respectfully submitted,



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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY DOCKET NO. 03500.017136.		APPLICATION NO. 10/656,242	
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				APPLICANT NOBUHIRO YASAI, ET AL.			
				FILING DATE September 8, 2003		GROUP 1773	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US 2004/0033339 A1	02/19/04	Fukutani et al.	428	137	
		US 2004/0043208 A1	03/04/04	Fukutani et al.	428	304.4	
		US 2005/0053773 A1	03/10/05	Fukutani et al.	428	209	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		JP 09-0157062 A	06/17/97	Japan			English Translation &
		JP 2001-261376	09/26/01	Japan			English Translation &
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		C.D. Adams, et al. "Monte Carlo Simulation of Phase Separation During Thin-Film Codeposition," J. Appl. Phys. 74 (3), 1 August 1993, American Institute of Physics, pp. 1707-1715.					
		C.D. Adams, et al. "Transition from Lateral to Transverse Phase Separation During Film Co-deposition," Appl. Phys. Lett. 59 (20), 11 November 1991, American Institute of Physics, pp. 2535-2537.					
		C.D. Adams, et al. "Phase Separation During Co-deposition of Al-Ge Thin Films," J. Mater. Res., Vol. 7, No. 3, March 1992, Materials Research Society, pp. 653-667.					
		M. Atzmon, et al. "Phase Separation During Film Growth," J. Appl. Phys. 42 (2), 15 July 1992, American Institute of Physics, pp. 442-446.					
		M. Jacobs, et al. "Unbalanced Magnetron Sputtered Si-Al Coatings: Plasma Conditions and Film Properties Versus Sample Bias Voltage," Surface and Coatings Technology 116-119 (1999) pp. 735-741.					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1